



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

OKU et al

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)
Examiner: Dang, T.

Serial No.: 09/903,764

) Art Unit: 2823

Filed: July 13, 2001

)

For: FILM FORMING METHOD, SEMICONDUCTOR
DEVICE AND SEMICONDUCTOR DEVICE
MANUFACTURING METHOD

)

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97(d)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

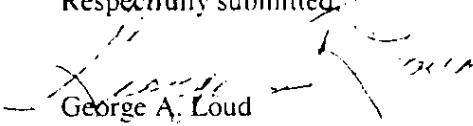
Sir:

It is respectfully requested that the examiner consider and cite of record the four (4) references listed on the attached, copies of which are submitted herewith. Also submitted herewith is a copy of a European Search Report issued July 23, 2003 in connection with EP Application No. 01 11 66 94, believed to correspond to the captioned application. The examiner will note that in addition to the four references submitted here, the European Search Report cites a fifth reference, i.e., the English language abstract of Japanese Publication 10-125669 which has already been made of record by the office action of October 24, 2002.

The undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three (3) months prior to today's date.

Our credit card payment form in the amount of \$180.00 is also submitted herewith to cover the fee required by 37 CFR 1.17(p).

Respectfully submitted,


George A. Loud
Reg. No. 25.814

Dated: September 3, 2003

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Image

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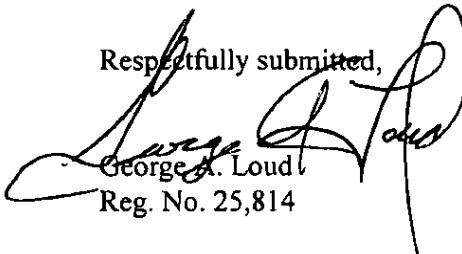
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the examiner consider and cite of record the three documents listed on the attached. Also submitted herewith is a copy of an office action issued by the Korean Patent Office on September 29, 2003 in connection with Korean Application No. 10-2001-004373 believed to correspond to the captioned application. This Korean office action cites as a reference Korean Patent Application 2002-9429. Also submitted herewith is a copy of EPO 1 174 916 believed to be an English language equivalent of the cited Korean document 2002-9429. Finally, also submitted herewith is a copy of European Application Publication No. 1174914 which is related to the aforementioned EPO publication. All of these publications are commonly owned by the assignee of the captioned application.

However, comparing their dates with the effective date of the present application, it does not appear that any of these documents are prior art against the captioned application.

Respectfully submitted,


George A. Loud
Reg. No. 25,814

Dated: October 29, 2003

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